

JAN 21 2009

Application Serial No. 10/594,174
ResponsePATENT
Docket: CU-5102**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

INVENTOR:	Hideshi Hattori et al.)	
APPLICANT	Dai Nippon Printing Co., Ltd)	EXAMINER: Kosson, Rosanne
SERIAL NO:	10/594,174)	
)	GROUP ART UNIT: 1652
FILED:	09/26/2006)	
TITLE:	METHOD FOR PRODUCING CELL CULTURE SUBSTRATE AND APPARATUS FOR PRODUCING CELL CULTURE SUBSTRATE		
Attorney	CU-5102		
Docket No.			

Mail Stop Amendment
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICIAL ACTION DATED DECEMBER 17, 2008

Dear Madam:

This is in response to the Office Action dated December 17, 2008 and having a shortened statutory period for reply set to expire on January 17, 2009.

REMARKS

In the Office Action the pending Claims 7-16 were restricted as follows:

Group 1: Claims 17-15, drawn to a method of making a cell culture substrate, comprising irradiating the substrate through a light-shielding portion to form a pattern of two types of areas, those to which cells do adhere and those to which cells do not adhere; and

Group 2: Claim 16, drawn to an apparatus for making a cell culture substrate comprising a cell culture chamber, a cell culture substrate, and a source of radiation.

The Applicant hereby elects Group 1; Claims 7-15. The Applicant retains the right

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to present the non-elected claims in a divisional application. The Applicant believes that this response is responsive to all points raised in the Office Action dated December 17, 2008.

Respectfully Submitted,



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